



**RESPONSE UNDER 37 C.F.R.  
§1.116 EXPEDITED PROCEDURE  
EXAMINING GROUP 1763**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

<b>Applicants:</b>	Yukio Morishige, et al.	<b>Examiner:</b>	Richard R. Bueker
<b>Serial No.:</b>	10/600,075	<b>Art Unit:</b>	1763
<b>Filed:</b>	June 20, 2003	<b>Docket:</b>	16748
<b>For:</b>	LASER CVD DEVICE AND LASER CVD METHOD	<b>Dated:</b>	August 30, 2006
		<b>Confirmation No.</b>	9161

Mail Stop AF  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT UNDER 37 C.F.R. § 1.116**

Sir:

In response to the Office Action of May 30, 2006, Applicants respectfully request entry of the following amendments under 37 C.F.R. § 1.116 that are believed to place the Application in condition of allowance.

**CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop AF, Commissioner for Patents, Box 1450, Alexandria, VA 22313-1450 on August 30, 2006.

Dated: August 30, 2006

  
Paul J. Esatto, Jr.